Docket No. 006282/FET/MDR/DSI/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Re:

Inventor(s):

Amos Dor and Yifah Gavra

Title:

Defect Source Identifier with Static Manufacturing Execution System

Transmitted herewith is the patent application identified above, including:

<u>X</u> Specification, claims and abstract, totaling 12 pages.

Drawings totaling $\frac{3}{2}$ pages, _ Formal X Informal. X

<u>X</u> Executed Declaration and Power of Attorney.

 \mathbf{X} Assignment of the invention to Applied Materials, Inc.

 \mathbf{X} Assignment Recordation Cover Sheet

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Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	6	- 20 =	0	X \$ 18.00	\$ 000.00
fndependent Claims	1	- 3 =	0	X \$ 84.00	\$ 000.00
Basic Filing Fee \$					\$ 740.00

- XXThe Commissioner is hereby authorized to charge \$\frac{\$740.00}{}\$ to Deposit Account No. \$\frac{50-1074}{}\$.
- The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to \underline{XX} Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

 \underline{XX} Please address all future correspondence to:

PATENT COUNSEL APPLIED MATERIALS, INC. Legal Affairs Department

P.O.BOX 450A

Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D C 20231

EV049834036US

Robert W. Mulcahy Registration/No. 25,436

Respectfully submitted,